

### AMENDMENTS TO THE CLAIMS

**Claim 1 (Currently Amended)** A production method of an organic light emitting element comprising steps of:

forming each layer of a transparent electrode and a metal layer sequentially on a transparent substrate;

forming a first electrode composed of the transparent electrode and the metal layer, the first electrode having a same width as a pixel;

exposing a strip-shaped area of the transparent electrode of the first electrode by removing the metal layer intersecting the transparent electrode which of an area corresponding corresponds to a the pixel, a size of the pixel being specified by a pair of opposite edges of the transparent electrode and a pair of opposite edges of the metal layer at the exposed strip-shaped area of the transparent electrode of the first electrode to expose the transparent electrode;

forming an organic layer to coat the exposed strip-shaped area of the transparent electrode; and

forming a second electrode on the organic layer.

**Claim 2 (Currently Amended)** The production method of an organic light emitting element as defined in claim 1, wherein the metal layer is formed of a metal that ~~can be~~ that is etched selectively instead of the transparent electrode.

**Claim 3 (Original)** The production method of an organic light emitting element as defined in claim 1, wherein the metal layer is formed of a metal having a work function smaller than a work function of the material of the transparent electrode.

**Claim 4 (Currently Amended)** The production method of an organic light emitting element as defined in claim 1, further comprising ~~a step of~~ forming an insulating layer on an upper surface of the metal layer.

**Claim 5 (Currently Amended)** The production method of an organic light emitting element as defined in claim 1, wherein the ~~step of removing the metal layer~~ further comprises a ~~step of~~ forming the metal layer to be not more than  $3\mu\text{m}$  thick at the pixel edge.

**Claim 6 (Currently Amended)** The production method of an organic light emitting element as defined in claim 1, wherein ~~the step of removing the metal layer~~ further comprises ~~steps of~~ providing the metal layer with a portion reducing in thickness toward the pixel edge, and forming at the pixel edge a stair of the metal layer on the transparent electrode so as to have a thickness not more than that of the organic layer.

**Claim 7 (Currently Amended)** The production method of an organic light emitting element as defined in claim 6, wherein the portion ~~thus reducing in thickness~~ is a slanting surface having an angle of 30 or less degrees toward the pixel edge.

**Claim 8 (Currently Amended)** The production method of an organic light emitting element as defined in claim 6, wherein the portion ~~thus reducing in thickness~~ is a stepped ~~form~~ such that the thickness reduces gradually toward the pixel edge.

**Claim 9 (Currently Amended)** The production method of an organic light emitting element as defined in claim 1, wherein the first electrode is a grid-shaped electrode separated electrically, and ~~the step of removing the metal layer~~ further comprises a ~~step of removing the metal layer~~ in a form of a strip so as to cross the grid-shaped electrode.

**Claim 10 (Currently Amended)** An organic light emitting element emitting light as a pixel, comprising:

a transparent electrode having a same width as a pixel formed on a transparent substrate;

a metal layer formed on the transparent electrode except for removing an a strip-shaped area corresponding to a the pixel on intersecting the transparent electrode;

an organic layer coating the transparent electrode at the strip-shaped area corresponding to the pixel, a size of the pixel being specified by a pair of opposite edges of the transparent electrode and a pair of opposite edges of the metal layer at an exposed area of the transparent electrode; and

a second layer formed on the organic layer.

**Claim 11 (Original)** The organic light emitting element as defined in claim 10, wherein an insulating layer is formed on the upper surface of the metal layer.

**Claim 12 (Original)** The organic light emitting element as defined in claim 10, wherein the metal layer is provided with a portion reducing in thickness toward the pixel edge, and a stair of the metal layer on the transparent electrode is formed at the pixel edge so as to have a thickness not more than that of the organic layer.

**Claim 13 (Currently Amended)** The organic light emitting element as defined in claim 12, wherein the portion ~~thus~~ reducing in thickness is a slanting surface having an angle of 30 or less degrees toward the pixel edge.

**Claim 14 (Currently Amended)** The organic light emitting element as defined in claim 12, wherein the portion ~~thus~~ reducing in thickness is a stepped form such that the thickness reduces gradually toward the pixel edge.

**Claim 15 (Previously Presented)** The organic light emitting element as defined in claim 10, wherein the transparent electrode is a grid-shaped electrode separated electrically.

**Claim 16 (Original)** An image forming device using the light emitting element defined in claim 15 as a light source thereof.

**Claim 17 (Original)** A display unit using the light emitting element defined in claim 15.

**Claim 18 (Currently Amended)** The production method of an organic light emitting element as defined in claim 2, wherein the first electrode is a grid-shaped electrode separated electrically, and the ~~step of~~removing the metal layer further comprises a ~~step of~~removing the metal layer in a form of strip so as to cross the grid-shaped electrode.

**Claim 19 (Currently Amended)** The production method of an organic light emitting element as defined in claim 3, wherein the first electrode is a grid-shaped electrode separated electrically, and the ~~step of~~removing the metal layer further comprises a ~~step of~~removing the metal layer in a form of strip so as to cross the grid-shaped electrode.

**Claim 20 (Currently Amended)** The production method of an organic light emitting element as defined in claim 4, wherein the first electrode is a grid-shaped electrode separated electrically, and the ~~step of~~removing the metal layer further comprises a ~~step of~~removing the metal layer in a form of strip so as to cross the grid-shaped electrode.